

Please Amend Claims 1 and 3 as follows:

1. (Currently Amended) A surface acoustic wave device comprising:
a piezoelectric substrate;
an electrode unit for exciting a surface acoustic wave on a
surface of said piezoelectric substrate; and

reflectors for reflecting the surface acoustic wave at said
reflectors, wherein:

said electrode unit comprises interdigital electrodes including a
thin-film layer formed of copper or a copper alloy, and a connecting electrode
connected to each of the interdigital electrodes; and

when the wavelength of the surface acoustic wave is indicated
by λ , and when the thickness of the interdigital electrodes is indicated by H ,
the standardized thickness H/λ of the interdigital electrodes ranges from
0.045 to 0.070, and said piezoelectric substrate is a rotated Y-cut LiTaO_3
substrate whose cut angle θ from the Y axis to the Z axis around the X
axis ranges from 52.0° to 58.0° , the surface acoustic wave propagating in
the direction of the X axis of said piezoelectric substrate.

2. (Original) A surface acoustic wave device according to claim 1,
wherein the standardized thickness H/λ of the interdigital electrodes ranges
from 0.050 to 0.065, and said piezoelectric substrate is a rotated Y-cut LiTaO_3
substrate whose cut angle θ from the Y axis to the Z axis around the X axis
ranges from 52.4° to 58.0° .

3. (Currently Amended) A surface acoustic wave device comprising:
a piezoelectric substrate;
an electrode unit for exciting a surface acoustic wave on a
surface of said piezoelectric substrate; and

reflectors for reflecting the surface acoustic wave at said
reflectors, wherein:

said electrode unit comprises an interdigital electrodes including a thin-film layer formed of copper or a copper alloy, and a connecting electrode connected to each of the interdigital electrodes; and

when ~~the~~a wavelength of the surface acoustic wave is indicated by λ , and when ~~the~~a thickness of the interdigital electrodes is indicated by H , ~~the~~a standardized thickness H/λ of the interdigital electrodes ranges from 0.050 to 0.065, and said piezoelectric substrate is a rotated Y-cut LiTaO_3 substrate whose cut angle θ from ~~the~~a Y axis to ~~the~~a Z axis around ~~the~~a X axis ranges from 50.0° to 59.5° , the surface acoustic wave propagating in ~~the~~a direction of the X axis of said piezoelectric substrate.